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In re the Application of:

Kazuo MAEDA

Serial No.: 09/519,599

Filed: March 6, 2000

For: METHOD AND APPARATUS FOR FORMING  
AN INTERLAYER INSULATING FILM,  
AND SEMICONDUCTOR DEVICE

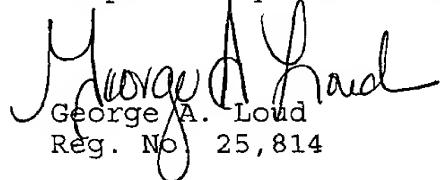
INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b) (1)

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

It is respectfully requested that the examiner consider and cite of record Japanese Kokai 9-275103, a copy of which is submitted herewith, along with a published English language abstract thereof. A "Kokai" is an 18-month publication of unexamined Japanese application.

Respectfully submitted,

  
George A. Loud  
Reg. No. 25,814

Dated: March 22, 2000

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